



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/805,620
Confirmation No.3004
Filing Date March 13, 2001
Inventor..... Craig M. Carpenter
Assignee Micron Technology, Inc.
Group Art Unit.....1762
Examiner E. Fuller
Attorney's Docket No.MI22-1563
Customer No.....021567
Title: Chemical Vapor Deposition Methods (Amended)

RESPONSE TO MARCH 10, 2004 OFFICE ACTION

To: Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS

Amendments to the Title begin on page 2 of this paper.

Amendments to the Specification begin on page 3 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 4 of this paper.

Remarks begin on page 12 of this paper.

EV 372452900

Amendments to the Title

Please amend the title as follows:

Chemical Vapor Deposition Apparatuses and Deposition Methods